

# Plasma and Dry Micro/Nanotechnologies

## 7. Plasma Treatment

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# Outline

- Plasma Treatment
  - 7.1 Introduction to Plasma Treatment
  - 7.2 Low Pressure Plasma Treatment
  - 7.3 Atm. Plasma Treatment for Adhesive Joints

# 7.1 Introduction to Plasma Treatment

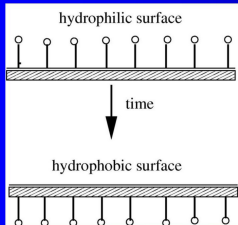
## Plasma Treatment

combination of various processes (chemistry, ions, UV) results in:

- removal of material
- modification of original material (especially important for polymers)
- grafting of new functional groups

In contrary to depositions the changes are limited to a very thin surface layer (in the order of nm) but please note that the term "surface" is a matter of definition!

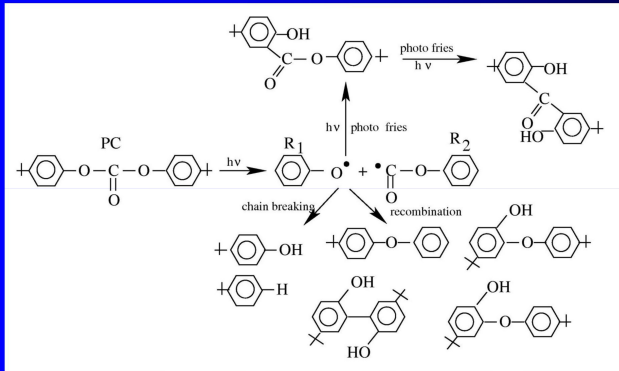
ageing of treated surfaces



important issue of any surface treatment processes

## Effect of UV Radiation on Polycarbonate

suggested mechanism of carbonate bond breakage due to UV radiation:



Plasma generates also UV photons and this effect is often forgotten!

## Plasma modifications of polymers in inert gas

➤ discharge in argon, helium:

chemical bonds, such as C-H, C-C, C=C, are broken

☞ generation of free radicals at or near the surface

☞ radicals react with each other either directly (if polymer chain is flexible enough) or due to migration along polymer chain („chain-transfer“)

☞ **cross-linking, branching, removal of low molecular weight material or its conversion into high molecular weight one (no new functional groups)**

**CASING**

(cross-linking by activated species of inert gas)

R. H. Hansen, H. Schonhorn, J. Polym. Sci. B 4 (1966) 203

H. Schonhorn, R. H. Hansen, J. Appl. Polym. Sci. 11 (1967) 1461



increase of surface hardness, improvement of adhesive forces at the interface

Additionally, changes of surface roughness

## Plasma treatment in reactive gases

### ➤ plasma containing oxygen ( $O_2$ , $H_2O$ , $CO_2$ ...)

- etching of surface carbon radicals by atomic oxygen
- new functional groups, e.g. C-O, C=O, O-C=O, C-O-O,  $CO_3$ , OH



hydrophilic surface, change of roughness

### ➤ plasma containing nitrogen ( $N_2$ , $NH_3$ ...)

- new functional groups such amine (N-C), imine (N=C), nitrile ( $N\equiv C$ ), amide (N-C=O)
- incorporation of oxygen and its functional groups
- grafting of amine groups  $-NH_2$



hydrophilization, biocompatibility, immobilization of biomolecules

### ➤ plasma containing fluorine ( $SF_6$ , $CF_4$ , $C_2F_6$ ...)

- F and  $CF_x$  radicals react with surface and two different processes compete:
- etching
  - grafting and deposition

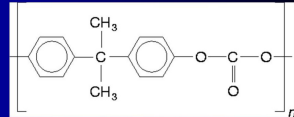


hydrophobization, change of roughness

## 7.2 Low Pressure Plasma Treatment

### Why Plasma Modification of Polycarbonate?

Polycarbonates are attractive business article, the most important PCs are based on on bisphenol A (Diflon<sup>®</sup>, Macrolon<sup>®</sup>, Lexan<sup>®</sup>)



### Properties

- excellent breakage resistance (15-20x than acrylate, 250x than glass)
- good transparency (3 mm thick – 90 %)
- low inflammability, good workability, lighter than glass
- low hardness (0.2 GPa)
- low scratch resistance
- degradation by ultraviolet light

replace glass and metals in:

- automobile headlamps, stoplight lenses,
- corrective lenses,
- safety shields in windows, architectural glazing

can be applied to:

- plastics vessels, parts of machines
- in optical grades for compact discs (CDs, CD-ROMs and DVDs), optical fibers

modification of PC surface properties is necessary

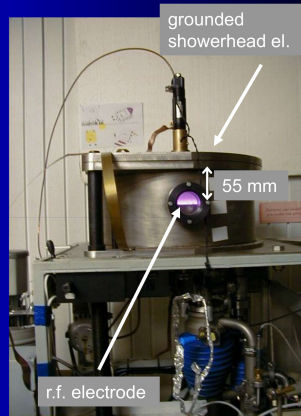
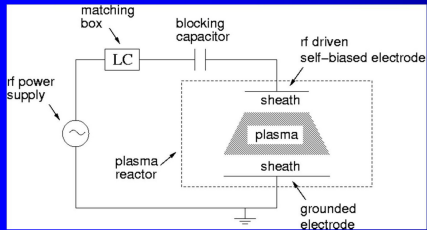
deposition of functional films (scratch resistant, reflective, ...)

surface treatment for improved film adhesion

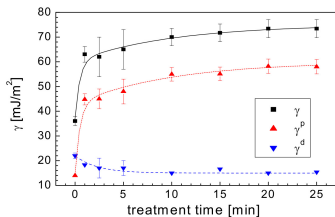
## Plasma treatment of polycarbonate in Ar or O<sub>2</sub> discharges (CCP)

External plasma parameters:

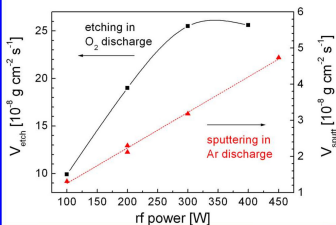
- $f = 13.56 \text{ MHz}$
- inner diameter of reactor 490 mm
- r.f. driven bottom electrode (420 mm)
- Ar, O<sub>2</sub>:  $Q = 5.7 \text{ sccm}$  ,  $p = 1.5 \text{ Pa}$
- r.f. power  $P = 100$  and  $400 \text{ W}$



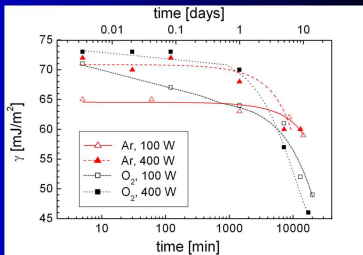


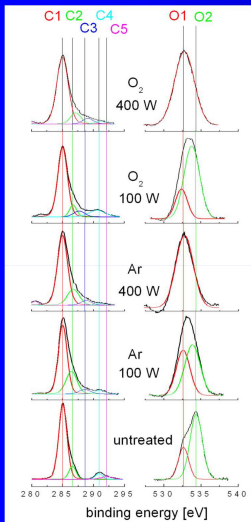


$P = 100 \text{ W}$ ,  $U_{\text{bias}} = -115 \text{ V}$ ,  $Q_{\text{ar}} = 5.7 \text{ sccm}$ ,  
 $p = 1.5 \text{ Pa}$



Plasma treatment of polycarbonate – etching rate and surface free energy





## Plasma treatment of polycarbonate – surface chemistry by XPS

	position [eV]	assignment
C1	285.0	C-C, C-H
C2	286.6	C-O
C3	288/289	C-C(=O)-C / O-C(=O)-O
C4	290.9	C-C(=O)-O
C5	292.1	shake up

gas	power [W]	C [at. %]	O [at. %]	Si [at. %]	N [at. %]
untreated		84.3	15.7	0	0
Ar	100	76.4	20.3	0.4	2.2
Ar	400	76.0	19.9	1.3	2.8
O <sub>2</sub>	100	74.0	24.0	0.4	1.7
O <sub>2</sub>	400	72.6	24.7	1.6	1.2

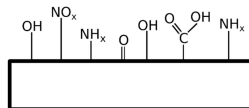
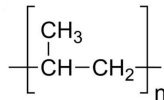
## 7.3 Atmospheric Pressure Plasma Treatment for Adhesive Joints

### Case study: Polypropylene (PP) adhesive joints with aluminium

General problem of PP (and other synthetic polymers):  
low free surface energy, chemical inertness



- ▶ Surface modification is required
- ▶ Added value is low, i. e. atmospheric pressure plasma treatment

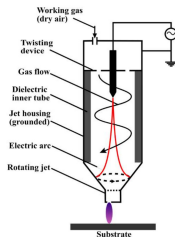
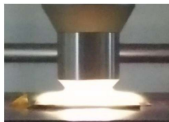


**Experiments: comparison of different atmospheric pressure plasma jets,** water contact angle, surface chemistry and topography, adhesive joint between PP and Al strips created with the epoxide adhesive DP 190 (3M)

## 7.3 PT & AFS Atm. Pressure Plasma Jets

Jet	Principle	Working gas	Working gas flow rate [slm]	Additive	Power [W]	Frequency	Treated area $\varnothing$ [mm]
Plasmatreat rotating plasma jet (PT)	Electrical arc	Dry air	30	–	1000	21 kHz	33
AFS Plasmajet® (AFS)	Electrical arc	Dry air	5–10	–	200–500	16–31 kHz	8
SurfaceTreat gliding arc (GA)	Electrical arc	Dry air	11.8	Ar	550	50 Hz	27–36
RF plasma slit jet (RF)	CCP/ICP	Ar	50–100	N <sub>2</sub>	300–600	13.56 MHz	150–300

 **plasmatreat**

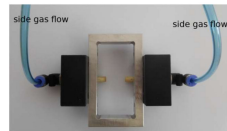
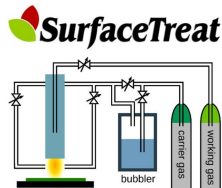
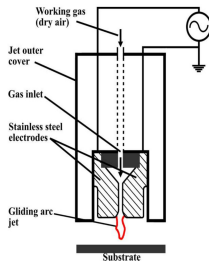
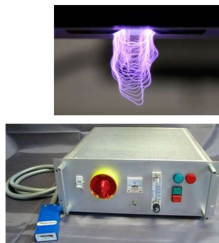


**AFS**<sup>®</sup>  
PLASMA CORONA PERFORATORS



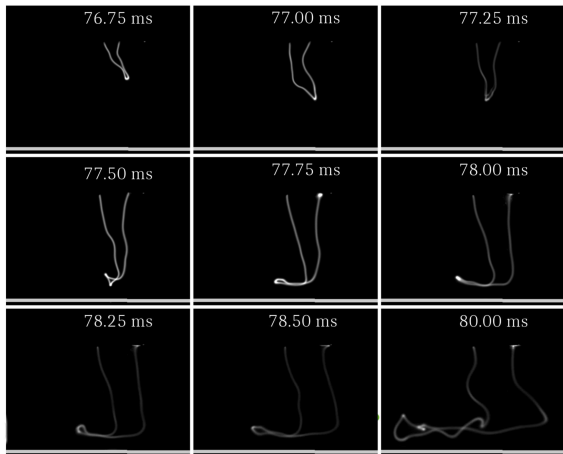
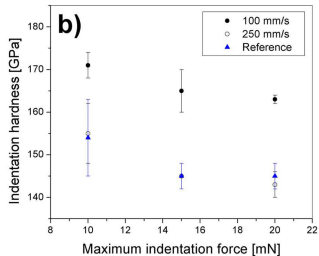
## 7.3 SurfaceTreat Atm. Pressure Plasma Jet

Jet	Principle	Working gas	Working gas flow rate [slm]	Additive	Power [W]	Frequency	Treated area $\varnothing$ [mm]
Plasmatrete rotating plasma jet (PT)	Electrical arc	Dry air	30	–	1000	21 kHz	33
AFS Plasmajet® (AFS)	Electrical arc	Dry air	5–10	–	200–500	16–31 kHz	8
SurfaceTreat gliding arc (GA)	Electrical arc	Dry air	11.8	Ar	550	50 Hz	27–36
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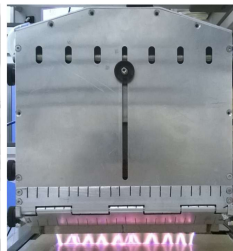
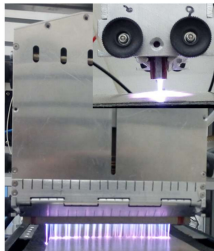
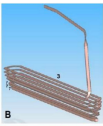
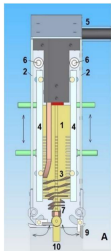
# Modification of Surface Treat Plasma Jet

- without a cross flow



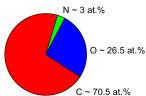
## 7.3 “Cold“ RF Plasma Slit Jet

Jet	Principle	Working gas	Working gas flow rate [slm]	Additive	Power [W]	Frequency	Treated area $\varnothing$ [mm]
Plasmatreat rotating plasma jet (PT)	Electrical arc	Dry air	30	–	1000	21 kHz	33
AFS Plasmajet® (AFS)	Electrical arc	Dry air	5–10	–	200–500	16–31 kHz	8
SurfaceTreat gliding arc (GA)	Electrical arc	Dry air	11.8	Ar	550	50 Hz	27–36
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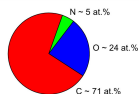
## 7.3 Results

### PP/Al joint's strength



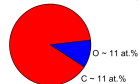
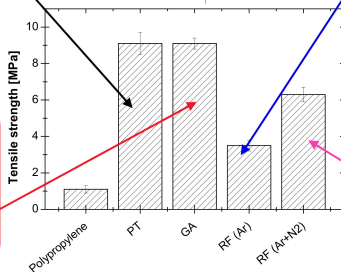
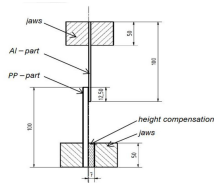
WCA =  $28 \pm 6^\circ$

1000 W, dry air 30 slm, 0.26 s,  
 $h = 5$  mm



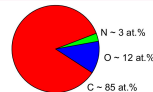
WCA =  $56 \pm 2^\circ$

550 W, dry air 11.8 slm + Ar  
3.5 slm, 1 s,  $h = 10$  mm



WCA =  $74 \pm 4^\circ$

500 W, Ar 50 slm, 0.6 s,  
 $h = 10$  mm



WCA =  $67 \pm 4^\circ$

600 W, Ar 100 slm + N<sub>2</sub> 3.5 slm,  
0.12 s,  $h = 10$  mm

**The best adhesion** ~ higher discharge gas temperature + presence of NH<sub>x</sub>/NO<sub>x</sub> groups